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Application Number	10/617,767
Filing Date	July 14, 2003
First Named Inventor	Jung-hyun LEE, et al
Art Unit	2822
Examiner Name	C. L. NOVACEK
Attorney Docket Number	249/349

# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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## U. S. PATENT DOCUMENTS

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## FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>2</sup>
		Country Code <sup>3</sup> * Number <sup>4</sup> * Kind Code <sup>5</sup> (if known)				
CK		EP 0 540 994 A1	05-12-1993	ARGOS, et al.		
		EP 1 341 217 A2	09-03-2003	LEE, et al.		
CK		WO 02/91875 A2/A3	04-18-2002	HAUKKA, et al.		
		JP 2001-267566 *	09-28-2001	MA, et al.		
		*=US 6,407,435				

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Sheet

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of

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**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		CHOI, et al., *, Jpn. J. of Applied Physics, 40(4B, Part 1):2940-2942, (April 2001)	
		* Entitled: "Electrical Characteristics of Pt/SrBi <sub>2</sub> Ta <sub>2</sub> O <sub>9</sub> /Ta <sub>2</sub> O <sub>5</sub> /Si Using Ta <sub>2</sub> O <sub>5</sub> as the Buffer Layer"	
		CLARK-PHELPS, et al., **, Mat. Res. Soc. Symp. Proc. Vol. 670, Society, K2-2.1-6 (2001)	
		** Entitled: "Engineered tantalum aluminate and hafnium aluminate ALD films for ultrathin ..."	
		WILK, et al., ***, Journal of Applied Physics, Vol. 89, No. 10:5243-5275, (May 15, 2001)	
		*** Entitled: "High-k gate dielectrics: Current status and materials properties considerations"	

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